

**Notice of References Cited**

Application/Control No.

10/750,554

Applicant(s)/Patent Under  
Reexamination  
NAVADA ET AL.

Examiner

Van Kim T. Nguyen

Art Unit

2152

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,463,067	10-2002	Hebb et al.	370/413
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
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